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RECORDA ENT APPLICATION

J1000 U.S. PTO
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12/31/02

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NAME OF CONVEYING PARTY	:	**Chih-Yung HUANG, Ting-Wei HUANG and Ching-Sung HSIAO**
NAME OF RECEIVING PARTY	:	**INDUSTRIAL TECHNOLOGY RESEARCH INSTITUTE**
ADDRESS OF RECEIVING PARTY	:	**195 Chung Hsing Road, Sec. 4, Chutung, Hsinchu, Taiwan, R.O.C.**
NATURE OF CONVEYANCE	:	Assignment of U.S. Patent Application
CONVEYANCE EXECUTION DATE	:	November 8, 2002
PATENT APPLICATION NO.	:	To be assigned
PATENT APPLICATION FILING DATE	:	December 31, 2002
APPLICATION FILED TOGETHER WITH THIS DOCUMENT	:	YES 10,331479
APPLICATION EXECUTION DATE	:	November 8, 2002
CORRESPONDENCE ADDRESS	:	RABIN & BERDO, P.C. 1101 14th Street, N.W., Suite 500 Washington, DC 20005 (Customer No: 23995)
ATTORNEY REFERENCE	:	LOU 105
TOTAL NUMBER OF PATENTS AND APPLICATIONS INVOLVED	:	One
TOTAL FEE PAID	:	$40.00
METHOD OF PAYMENT	:	☒ Enclosed ☐ Authorized to be charged to deposit account

FEE ENCLOSED $ 40
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To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Steven M. Rabin (Reg. No. 29,102)

December 31, 2002
Date

Total number of pages including cover sheet, attachments and document: 2.

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ASSIGNMENT OF U.S. PATENT APPLICATION

In consideration of the sum of One Dollar in hand paid, and other good and valuable consideration, the receipt of which is hereby acknowledged, the undersigned

Inventor(s) Full Name(s): Chih-Yung HUANG
Ting-Wei HUANG
Ching-Sung HSIAO

Hereby sell, assign and transfer to

Assignee Name and Address: INDUSTRIAL TECHNOLOGY RESEARCH INSTITUTE
No. 195, Chung Hsing Road, Sec. 4, Chutung,
Hinchu, Taiwan, R.O.C.

(hereinafter called the Assignee) the entire right, title, and interest in and to any and all improvements which are disclosed in the Application for United States Letters Patent entitled

Title of Invention: ⟹ MICROWAVE PLASMA PROCESSING APPARATUS

Which application was

Complete either a) executed by the undersigned on 11-8-2002
b) filed on the
Serial No.

Including any and all United States Letters Patents which may be granted therefore and any and all extensions, divisions, reissues, substitutes, renewals or continuations thereof, and the right to all benefits under the International Convention for the Protection of Industrial Property.

It is hereby authorized and requested that the Commissioner of Patents issue any and all of said Letters Patent, when granted, to said assignee.

Further, it is agreed that, when requested, without charge to but at the expense of said Assignee, the undersigned will execute all divisional, continuing, substitute, renewal, and reissue patent applications; execute all rightful other papers; and generally do everything possible which said Assignee shall consider desirable for aiding in securing and maintaining proper patent protection.

Date Signed at: HSINCHU, TAIWAN, R.O.C.
On: Nov. 08, 2002

Inventor(s) Full Signature(s):
Chih-Yung Huang, Nov. 8 2002 Chih-Yung HUANG
Ting-Wei Huang. Nov. 08. 2002 Ting-Wei HUANG
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